

Notice of References Cited	Application/Control No. 10/829,392		Applicant(s)/Patent Under Reexamination WAGNER ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,874,510 □□	04-2005	Reder et al.	134/1.3
*	B	US-5,759,416	06-1998	Bosman et al.	216/13
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*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Jurik et al.; Laser – Assisted Particle Removal; 11/24/2003
	V	Rizvi et al.; Direct manufacture of Miniature Bio-Particle Electro-manipulator Devices using Excimer Laser Mask Projection Techniques; 1998; Exitech Limited, Long Hanborough, Oxford OX8 8Lh, UK□□
	W	Scott; Overview of Spin Coating; 12/01/2000; www.polymerprocessing.com□□
	X	Knowles et al.; Micromachining of Metals, Ceramics, Silicon and Polymers using Nanosecond Lasers

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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	W	Bostanjoglo et al.; Design of variable reflective mirrors and unstable resonators for ND: YAG lasers with high average power; 1994; IOP Publishing
	X	Chang et al.; Micro-optic fabrication using laser ablation process; Proc. SPIE Vol. 4760, p. 1014-1023, High-Power Laser Ablation IV, Claude R. Phipps; 09/2002

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	V	dictionary.com; perimeter; 2006
	W	msn encarta; thesaurus; vacate; 2006
	X	semiconductor glossary; 6/6/2003; definition crystal; www.semiglossary.com

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